EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L4	1	((substraate or semiconductor or wafer) and nozzle and inert and gas and determin$3 and direction and speed).clm.	US-PGPUB	ADJ	ON	2008/03/04 22:35
L7	22	(dry$3 and (substrate or semiconductor or wafer) and nozzle and (hole or opening or aperture or perforation) and number).clm.	US-PGPUB	ADJ	ON	2008/03/04 22:39